Interface Control Document of LCGT

Subgroup Name	Vibration Isolation System
Subgroup Leader	Ryutaro Takahashi
	National Astronomical Observatory of Japan
Sub-leader	Takashi Uchiyama
	Institute for Cosmic Ray Research
Sub-leader	Shinji Miyoki
	Institute for Cosmic Ray Research

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APPROVAL AUTHORITIES

Concise definition of vibration isolation system

System requirement

Displacement of the test mass mirrors must be less than $6x10^{-18}$ m/Hz^{1/2} at 5Hz where the seismic noise and the radiation pressure noise are crossed. RMS motion must be less than 0.1μ m. The test mass mirrors are cooled to 20K through heat links.

SAS

Core optics are suspended by SASs. Two kinds of SASs are used in LCGT. Type-A SAS consists of an IP, three stage MGAS filters and a cryogenic mirror suspension. Type-B SAS consists of an IP, two stage MGAS filters and a mirror suspension. Type-A SASs are used for FM1, FM2, EM1 and EM2. Type-B SASs are used for BS, PRM, SEM, MC2F and MC2E.

Stack

Three stage stacks are used for BS, PRM, SEM, MC2F, MC2E, MC1F, MC1E, MMT and PD. Rubbers are enclosed by welded bellows. Some optics are placed on the stage 0.

Glossary

SAS	Seismic Attenuation System
IP	Inverted Pendulum
MGAS	Monolithic Geometric Anti Spring
PF	Platform
IM	Intermediate Mass
МВ	Magnet Box
TM	Test Mass
RM	Recoil Mass
ACC	Accelerometer
LVDT	Linear Variable Differential Transformer
FM	Front Mirror
EM	End Mirror
BS	Beam Splitter
PRM	Power Recycling Mirror
SEM	Signal Extraction Mirror
MC	Mode Cleaner
MMT	Mode Matching Telescope
PD	Photo Detector
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Figure: Schematic drawing of the vibration isolation system.

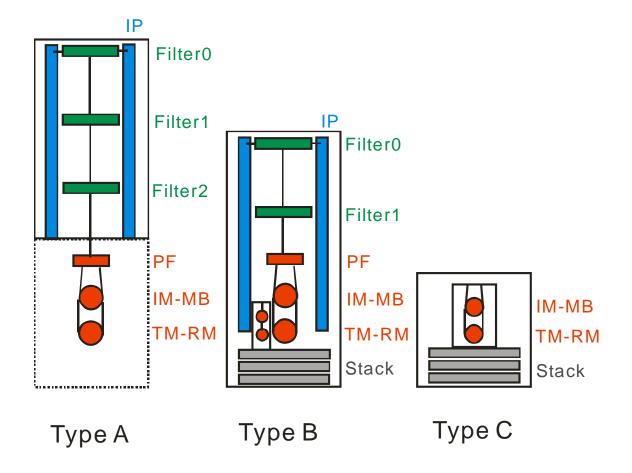


Table: Specification of the vibration isolation system

	#	Electric	Interface
		Lioutilo	Vacuum
30mHz			rasaani
00111112	3		
∠10 ⁻¹⁰ m /Hz ^{1/2} @1Hz		DC15V	Control
			Control
·			Control
•	3	?	Control
H: 0.55Hz, V: 0.2Hz	4		
	-	4.01.00\/	0
0.5511 0.011	ı	ACTOOV	Control
H: U.55HZ, V: U.2HZ	4		
0.511 0.011	ı		
H: 0.5Hz, V: 0.2Hz			
1.417	ı		
V: 0./Hz		4.04.00) (
4 04			Control
	8	DC15V	Control
			Cryostat
			•
			Cryostat
	?		
			Optics
?		DC15V	Control
00 11	5		Vacuum
30mHz	•		
10 1/2			
			Control
<10 ⁻⁸ m/Hz ^{1/2} @1Hz	3	DC15V	Control
10mm/V	3	DC15V	Control
?	3	?	Control
H: 0.55Hz, V: 0.2Hz			
	1		
	1	AC100V	Control
H: 0.55Hz, V: 0.2Hz			
	1		
V: 2Hz	4		
	4	AC100V	Control
1mm/V	8	DC15V	Control
?	?		
	•		Optics
?	4	DC15V	Control
	? H: 0.55Hz, V: 0.2Hz H: 0.55Hz, V: 0.2Hz V: 2Hz 1mm/V ?	\$\left\{10^{-10}\text{m/Hz}^{1/2}@1\text{Hz}} \\ 3\\ \left\{10^{-8}\text{m/Hz}^{1/2}@1\text{Hz}} \\ 3\\ 10\text{mm/V} \\ 3\\ \\ \\ \\ \\ \\ \\ \\ \\ \\ \\ \\	30mHz 30mHz 31

		#	Electric	Interface
Stack	2Hz	9		Vacuum
Stage 0				
Breadboard		1		
Bellows		3		
Rubber		3		
Stage 1				
Block		3		
Bellows		9		
Rubber		9		
Stage 2				
Block		3		
Bellows		9		
Rubber		9		